IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Applicant(s):	JANGJIAN, Shiu-Ko, et al.	**Docket No.:**	39524.8100
Serial No.:	10/679,764	**Group Art Unit:**	1762
Filed:	October 6, 2003	**Examiner:**	David P. Turocy
Title:	**METHOD OF FORMING INTER-METAL DIELECTRIC LAYER STRUCTURE**	**Confirmation No.:**	8562

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Dear Sir:

In response to the Notice of Non-Compliant Amendment mailed July 9, 2008, in connection with U.S. Patent Application No. 10/679,764, Applicant hereby submits a revised listing of the claims.

CORRECTED Amendments to the Claims as reflected in the listing of claims, begin on page 2 of this paper.

Conclusion begins on page 5 of this paper.